

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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## Title of Invention

METHODS FOR MANUFACTURING A FINFET USING A  
CONVENTIONAL WAFER AND APPARATUS MANUFACTURED  
THEREFROM

Application Number :

Confirmation Number:

First Named Applicant: Huilong Zhu

Attorney Docket Number: FIS920030413

Art Unit:

Examiner:

Search string: ( 6475869 or 6391695 or 6642090 or 6611029 or 6610576 or 6605514 or 6583469  
or 6580137 or 6562665 or 6525403 or 6521502 or 6492212 or 6475890 or 6451656  
or 6413802 or 6403434 or 6300182 or 20030102497 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6475869	2002-11-05	Yu			
	2	6391695	2002-05-21	Yu			
	3	6642090	2003-04-11	Fried et al.			
	4	6611029	2003-08-26	Ahmed et al.			
	5	6610576	2003-08-26	Nowak			
	6	6605514	2003-08-12	Tabery et al.			
	7	6583469	2003-06-24	Fried et al.			
	8	6580137	2003-06-17	Parke			
	9	6562665	2003-05-13	Yu			
	10	6525403	2003-02-25	Inaba et al.			
	11	6521502	2003-02-18	Yu			
	12	6492212	2002-12-10	leong et at.			
	13	6475890	2002-11-05	Yu			
	14	6451656	2002-09-17	Yu et al.			
	15	6413802	2002-07-02	Hu et al.			
	16	6403434	2002-06-11	Hu et al.			
	17	6300182	2001-10-09	Yu			

## US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030102497	2003-06-05	Fried et al.			

**Signature**

Examiner Name	Date